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202-955-5771

RADER FISMAN AND GRA

PAGE 01/05

Docket No.: HOK-0290

PATENT APPLICATION

26 JUL 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of: Takayoshi TANIZAWA, et al.

Application No.: 10/553,734

Filing Date: October 20, 2005

For: MASSAGE PROGRAM CONTROL METHOD, MASSAGE MACHINE USING THE METHOD, AND CONTROLLER FOR THE MASSAGE Confirmation No.: 7774

Group Art Unit: 3764

MACHINE

REQUEST FOR CORRECTED FILING RECEIPT

VIA FACSIMILE: 571-273-3201

Attention: PCT Section, Customer Service Center

Commissioner for Patents

P.O. Box 1450

Washington, D.C. 22313-1450

Sir:

- 1. Attached is a copy of the official filing receipt received from the USPTO in the above application for which issuance of a corrected filing receipt is respectfully requested. Also enclosed is the first page of the executed Japanese language declaration showing the correct data.
- 2. There is an error with respect to the following, which is incorrectly entered.

Error:

1. Title

Correct data to title:

1. MASSAGE PROGRAM CONTROL METHOD, MASSAGE MACHINE USING THE METHOD, AND CONTROLLER FOR THE MASSAGE MACHINE

The correction is due to an error by the USPTO. If any fee is due, please charge Deposit Account No. 18-0013.

Dated: July 19, 2006

Tel. No.: (202) 955-3750

Brian K. Dutton Reg. No. 47,255

Rader, Fishman & Grauer, PLLC 1233 20th Street, N.W., Suite 501

Washington, DC 20036 Customer No.: 23353



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APPL NO. | FILING OR 371 | ART UNIT | FIL FEE REC'D | ATTY DOCKET NO | DRAWINGS | TOT CLMS | IND CLMS | 10/553,734 | 10/20/2005 | 3764 | 900 | HOK-0290 | 7 | 12 | 3

CONFIRMATION NO. 7774 ~

23353
RADER FISHMAN & GRAUER PLLC
LION BUILDING
1233 20TH STREET N.W., SUITE 501
WASHINGTON, DC 20036

Date Mailed: 06/28/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiting about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Takayoshi Tanizawa, Osaka, JAPAN; Masamichi Miyaguchi, Osaka, JAPAN; Fumihiro Nishio, Osaka, JAPAN; Daisuke Tsukada, Osaka, JAPAN; Yuichi Nishibori, Osaka, JAPAN; Motoharu Muto, Osaka, JAPAN;

Power of Attorney: The patent practitioners associated with Customer Number 23353.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/05832 04/22/2004

Foreign Applications

JAPAN 2003-117504 04/22/2003

If Required, Foreign Filing License Granted: 06/21/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is US10/553,734

Projected Publication Date: 09/28/2006

Non-Publication Request: No

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Early Publication Request: No

Title

Method of controlling massage program, massage machine using the method, and controller for the massage machine controller for the massage machine.

Preliminary Class
601

"Massage program control method, Massage machine using the method, and controller for the massage Machine"

PROTECTING YOUR INVENTION OUTSIDE THE UNITED STATES

Since the rights granted by a U.S. patent extend only throughout the territory of the United States and have no effect in a foreign country, an inventor who wishes patent protection in another country must apply for a patent in a specific country or in regional patent offices. Applicants may wish to consider the filing of an international application under the Patent Cooperation Treaty (PCT). An international (PCT) application generally has the same effect as a regular national patent application in each PCT-member country. The PCT process simplifies the filing of patent applications on the same invention in member countries, but does not result in a grant of "an international patent" and does not eliminate the need of applicants to file additional documents and fees in countries where patent protection is desired.

Almost every country has its own patent law, and a person desiring a patent in a particular country must make an application for patent in that country in accordance with its particular laws. Since the laws of many countries differ in various respects from the patent law of the United States, applicants are advised to seek guidance from specific foreign countries to ensure that patent rights are not lost prematurely.

Applicants also are advised that in the case of inventions made in the United States, the Director of the USPTO must issue a license before applicants can apply for a patent in a foreign country. The filing of a U.S. patent application serves as a request for a foreign filing license. The application's filing receipt contains further information and guidance as to the status of applicant's license for foreign filing.

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202-955-5771

PTO/SB/106 (5-00) Approved for use through 10/3 1/02. OMB 0651-0032
Patent and Trademark Office, U.S. DEPARTMENT OF CONMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respired to a collection of information unless it displays a Valid CMB control number.

Declaration and Power of Attorney for Patent Application 特許出願宜言書及び委任状 Japanese Language Declaration 哲含显磁本日 私は、以下に記名された税助者として、ここに下記の通り賃貸する! As a below named inventor, I hereby declare that: 私の住所、超便の宛先をして国籍は、私の氏名の鉄に記載された連 My residence, post office address and officenship are as stated りである。 下記の名称の見明について、特許請求難因に記載され、且つ特許が 求められている見明主意に関して、私は、最初、最先且つ唯一の見贈 者である(唯一の氏者が超減されている場合)か、或いは最初、最先 I bollove I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which 且つ共同発明者である(複数の氏名が記載されている場合)と信じて a patent is sought on the invention entitled MASSAGE PROGRAM CONTROL METHOD, MASSAGE MACHINE USING THE METHOD, AND CONTROLLER FOR THE MASSAGE MACHINE the specification of which is attached hereto unless the following 上記丸明の財糧者はここに減付されているが、下記の何がチェック box is checked: きれている場合は、この取りでない: April 22, 2004 (XI) was filled on の日に出頭され、 as United States Application Number or この出版の米国出版者号またはPC丁国際出版者号は、 PCT International Application Number PCT/JP2004/005832 and was amended on _ であり、且つ の日に補正された出版 (数当する場合) (if applicable). 払は、上記の神正書によって袖正された、特許諸求報題を含む上記 明岡省を投討し、且つ内徴を理解していることをここに表現する。 I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment referred to above. I acknowledge the duty to disclose information which is metertal to petentability as defined in Title 37. Code of Federal Regulations.

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Section 1.56.

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